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April 20, 2005

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Art Unit 2823

Re: U.S. Utility Patent Application
Application No. 10/750,834; Filed: January 5, 2004
For: **High Density Metal Capacitor Using Via Etch Stopping Layer as Field Dielectric in Dual-Damascene Interconnect Process**
Inventor: Liming Tsau
Our Ref: 1875.0230001

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Credit Card Payment Form (PTO-2038);
2. Amendment And Reply Under 37 C.F.R. 1.111;
3. Terminal Disclaimer To Obviate A Double Patenting Rejection Over a Prior Patent; and
4. One (1) Return Postcard.

It is respectfully requested that the attached postcard be stamped with the date of filing of these documents, and that it be returned to our courier. In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

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